



A&T AUTOMATION & TESTING

La digitalizzazione dei servizi metrologici e dei certificati di taratura

In collaborazione con INRiM

14 febbraio 2024



Il progetto europeo “Metrologia per la fabbrica del futuro”

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Funded Research Project Manager SPEA S.p.A.

Torino, 14 Febbraio 2024

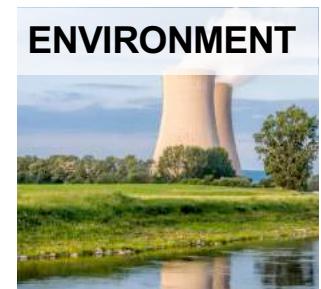
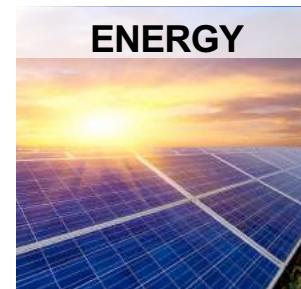
EURAMET's Research Programme

EURAMET's research programme **EMPIR** enables European metrology institutes, industrial & medical organisations, and academia to collaborate on **Joint Research Projects (JRPs)**.

The projects are centred around fields like **Industry, Energy, Environment, Health and Capacity Building**. The programme also supports the development of the fundamental **SI system** of measurement units.

EMPIR follows on from the **EMRP** programme, which has now been successfully completed.

See <https://www.euramet.org/> for more details.

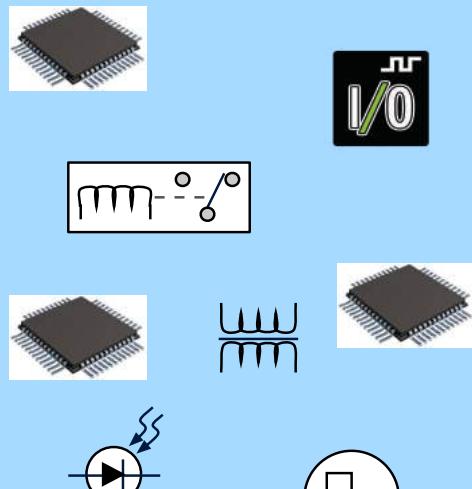


EMPIR

The EMPIR initiative is co-funded by the European Union's Horizon 2020 research and innovation programme and the EMPIR Participating States

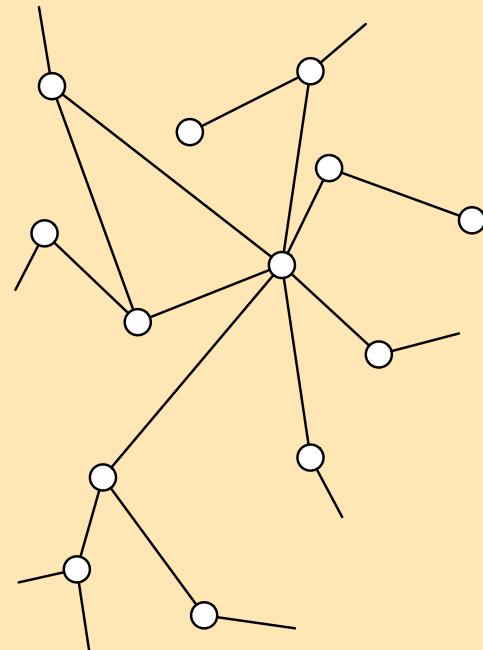
Met4FoF - Metrology for the Factory of the Future

Digital sensors and smart traceability



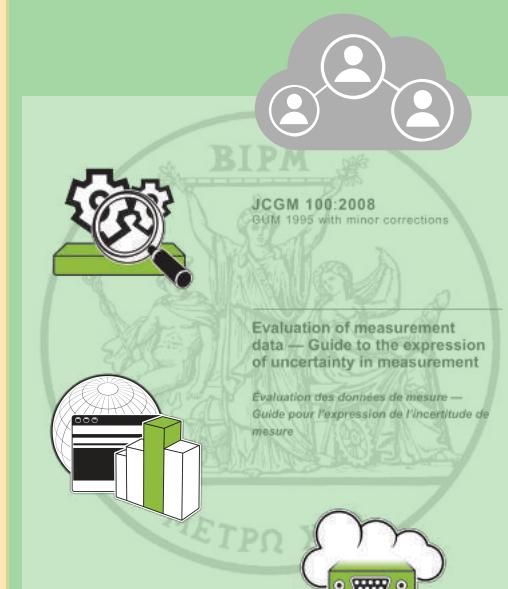
Dynamic, digital-only output and low-cost MEMS sensors

Reliable smart sensor networks



Synchronisation, co-calibration and sensor fusion

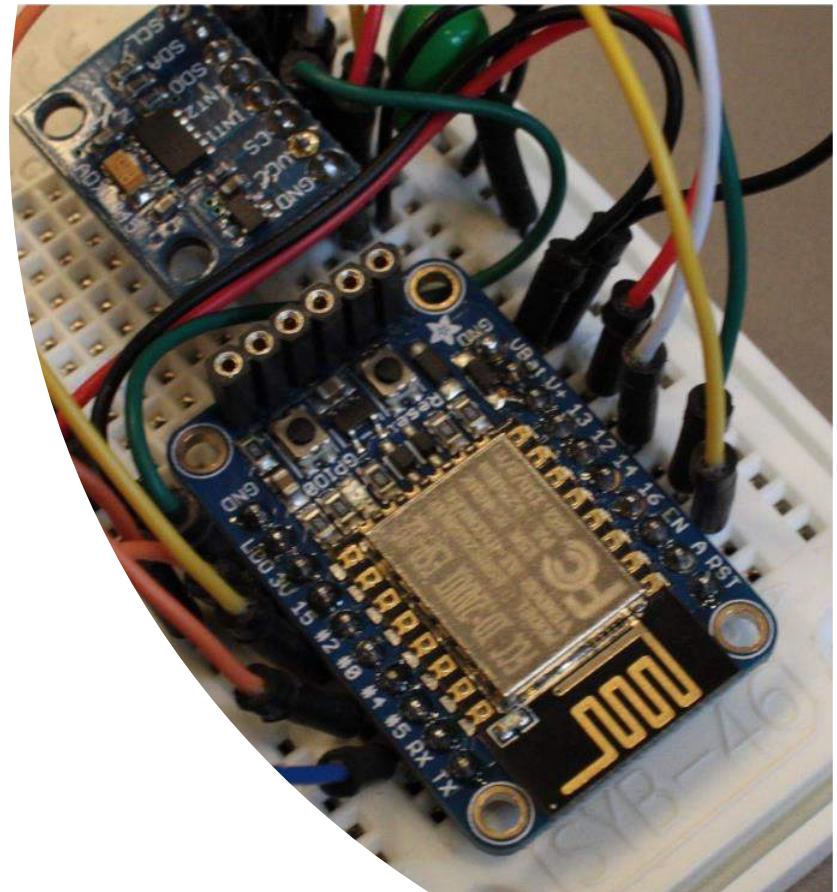
Confidence in smart data analysis methods



Measurement uncertainty in machine learning and AI

Project objectives

- Develop calibration framework for sensors with digital pre-processed output and internal signal processing.
- Develop a reference system for in-situ calibration of MEMS measuring ambient conditions.
- Develop metrological infrastructure for real-time data aggregation and machine learning in industrial sensor networks.
- Implement the methods and frameworks developed in industry-like test environments.



About SPEA

WHO WE ARE

A global leader
in test equipment
for Semiconductors, MEMS and
Sensors, Electronic Boards,
Batteries and devices.

Since 1976.

 SPEA



€210M
2023 Global Revenues
+6% yoy
+20% Average 2020-2023



12,000
Systems installed
worldwide

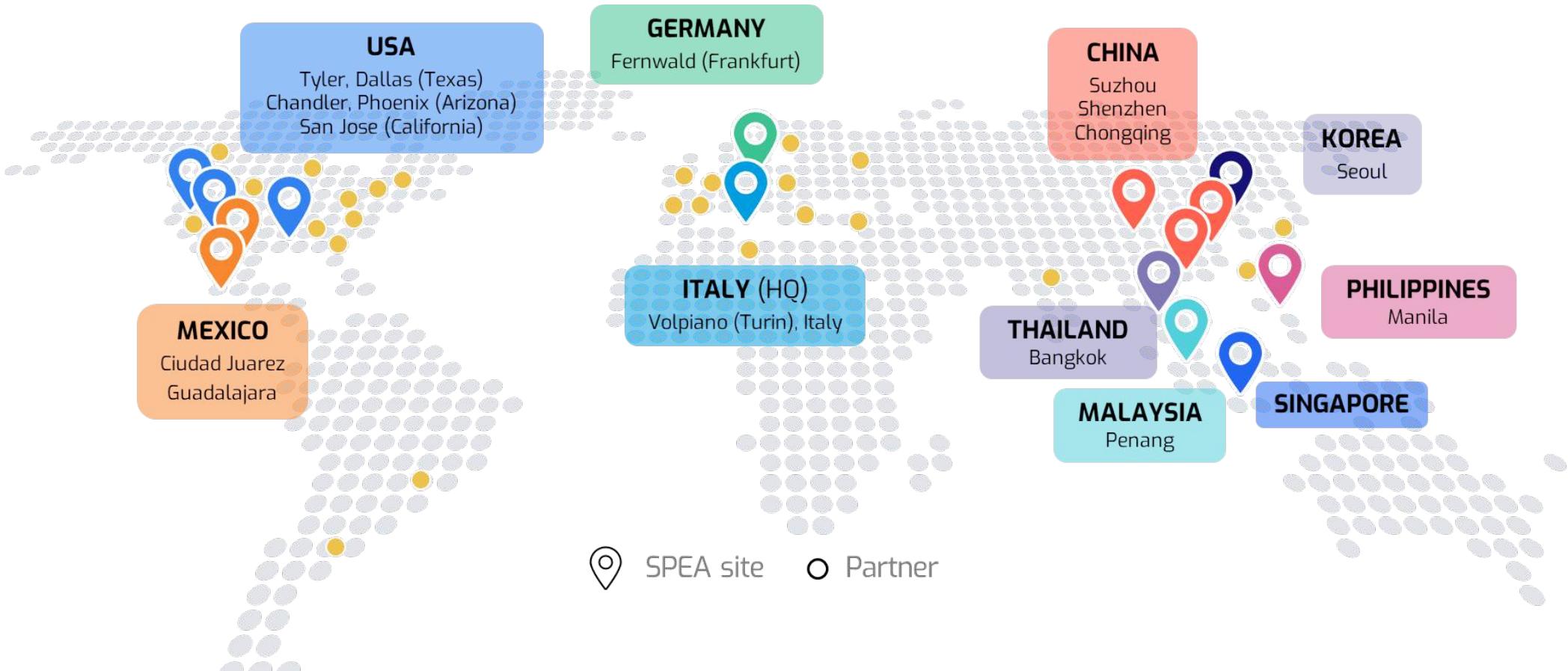


39
global locations
15
direct operations



serving
1,800+ customers
in
65+ countries

Global presence



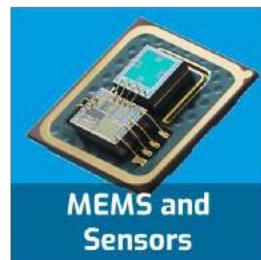
Tested Products



ICs



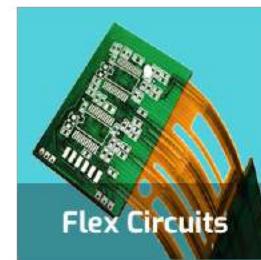
Si/SiC/GaN
Wafers



MEMS and
Sensors



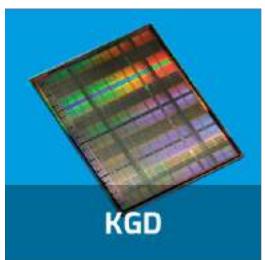
PCBAs



Flex Circuits



Power Supplies



KGD

**SEMICONDUCTOR
INDUSTRY**

**ELECTRONICS
INDUSTRY**



Touch Displays



Discretes



DBC



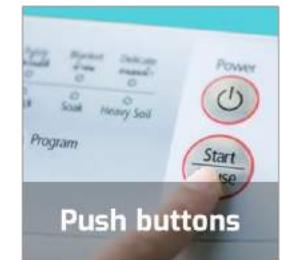
Power Modules



Battery Cells,
Modules, Packs

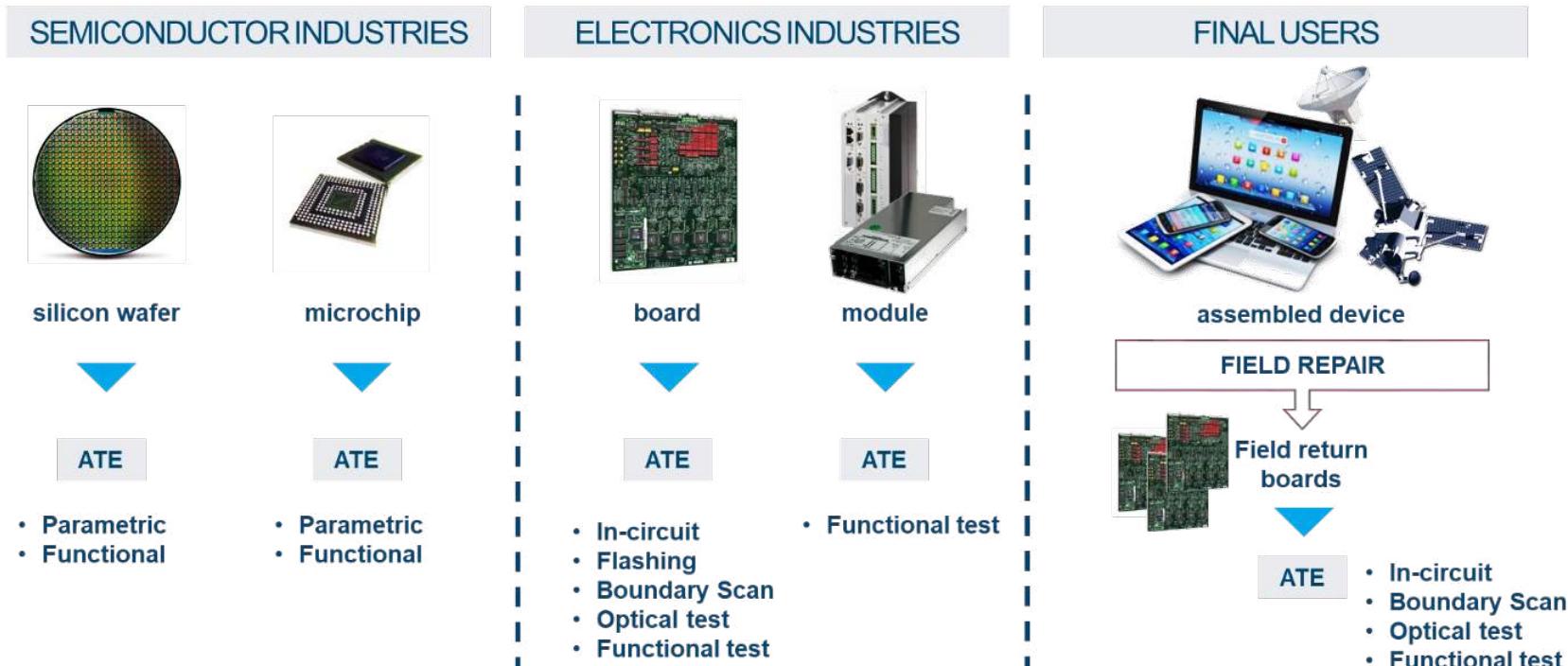


LED Panels



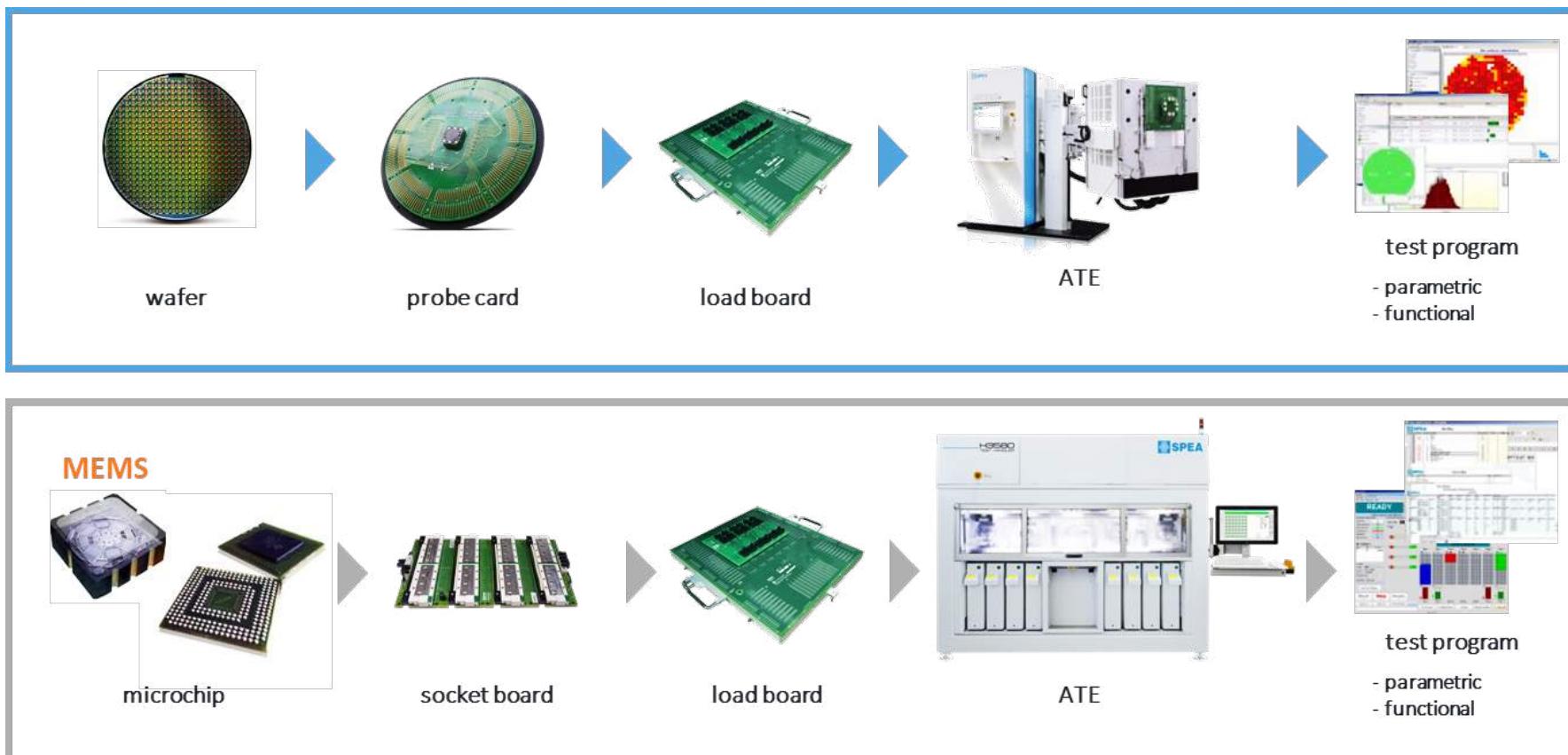
Push buttons

Electronic testing world



ATE stands for **AUTOMATIC TEST EQUIPMENT**: industrial machines able to perform all the operations required to verify the correct working of an electronic product

Wafer-level and chip-level testing



Product Lines



Semi & MEMS Test

- MEMS test cells
- Mixed Signal, Analog & SoC testers
- Power device testers
- Test handlers

Electronics Test

- ICT testers
- Flying probe testers
- Functional & EOL testers
- Battery testers
- Automatic board handlers
- Custom test equipment

SPEA is the only ATE manufacturer whose product portfolio embraces all the phases of testing.

From semiconductor wafer test to packaged IC and MEMS sensor test, from in-circuit and flying probe test on assembled PCBs to final functional test of assembled devices, performed with dedicated custom equipment.

Industries served

 Industrial	 Automotive	 Consumer			
 Medical	 Aerospace & Defense	 Identification			
 Lighting	 Energy & Power	 Home Appliance			

Market Goals



Power & Automotive

Exploit our position of strength in the Power and Automotive Market, taking advantage of the growth trend of this market

Micro controllers

Grow our presence in the microcontroller test market, with dedicated test instrumentation development

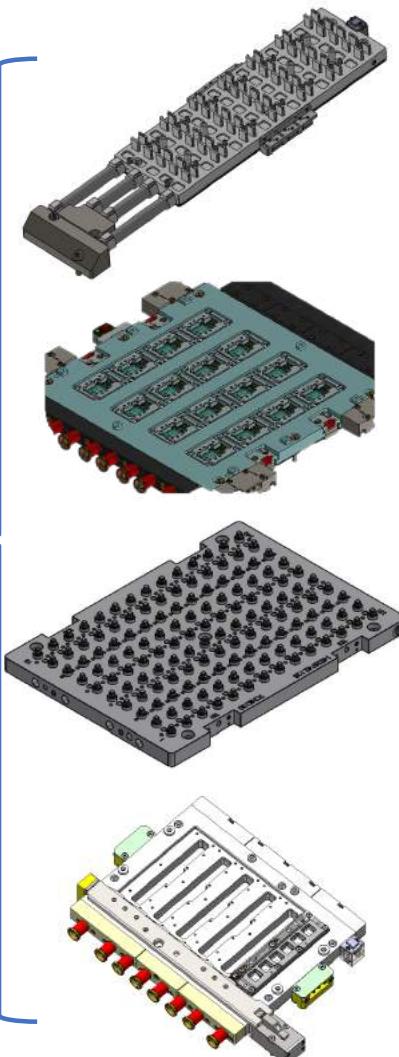
5G & mmWave

Grow our presence in the RF, 5G & mmWave market segments, with dedicated test instrumentation and low-cost complete test solutions

Computing & Network

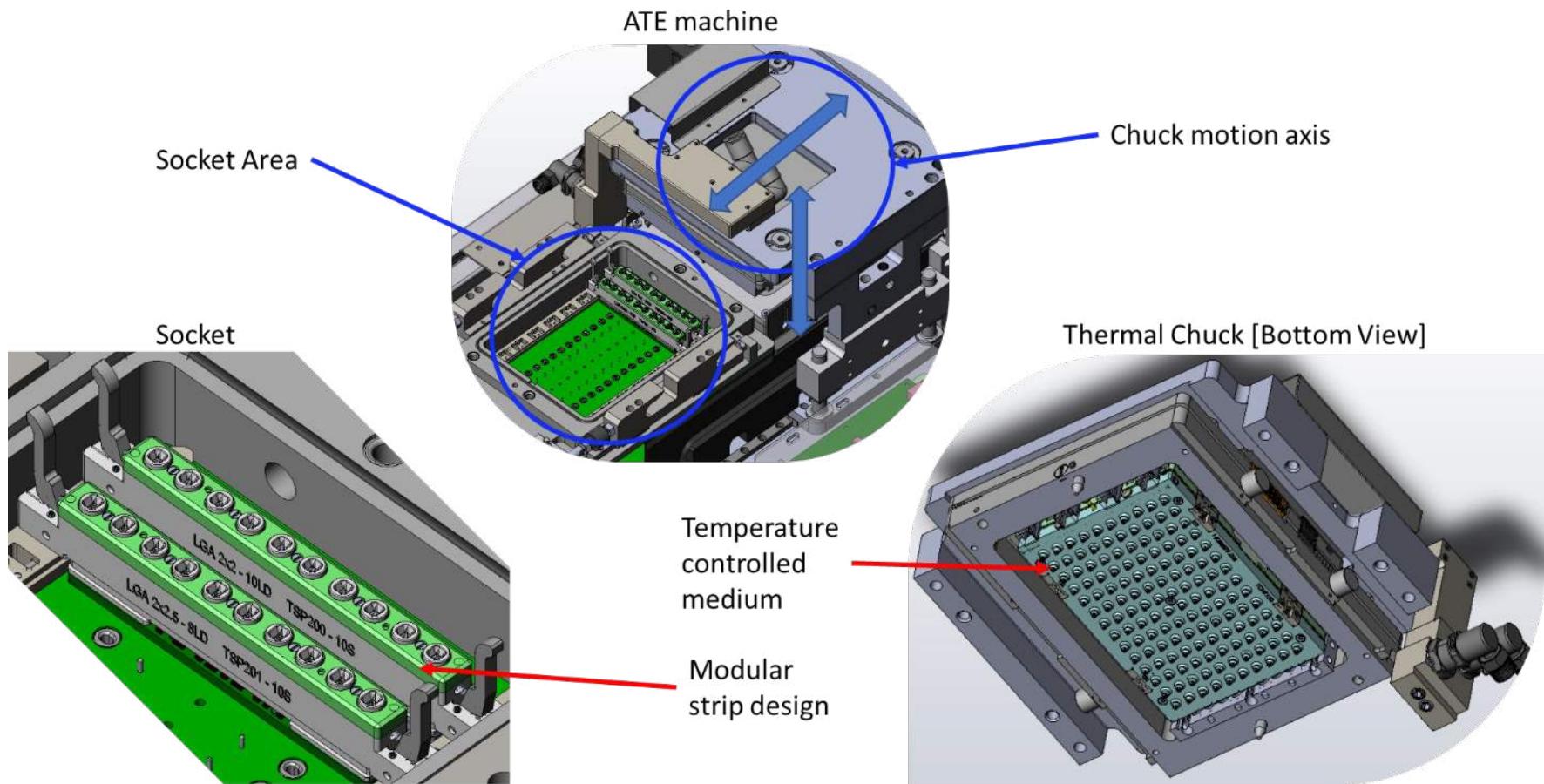
Expand our presence in the computing and networking market, with dedicated digital test instrumentation

SPEA and MET4FoF

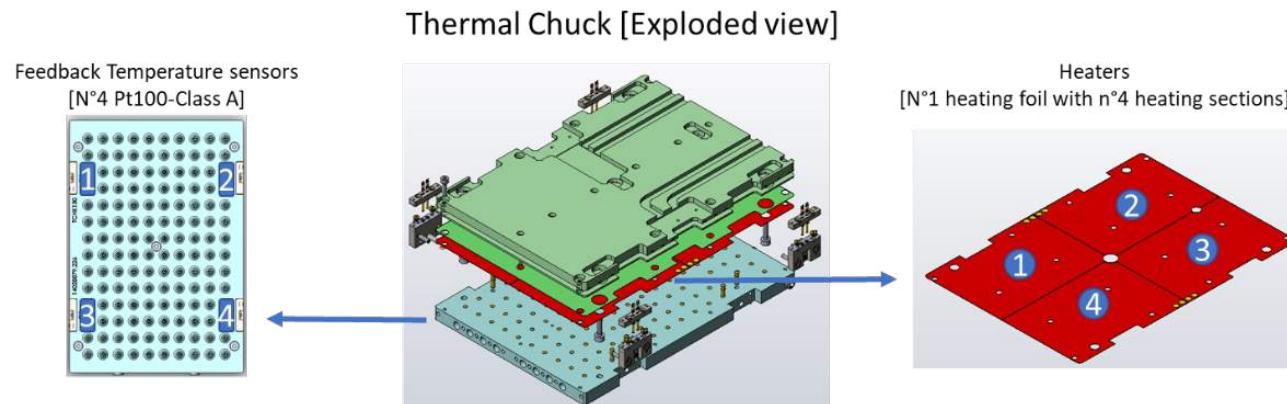
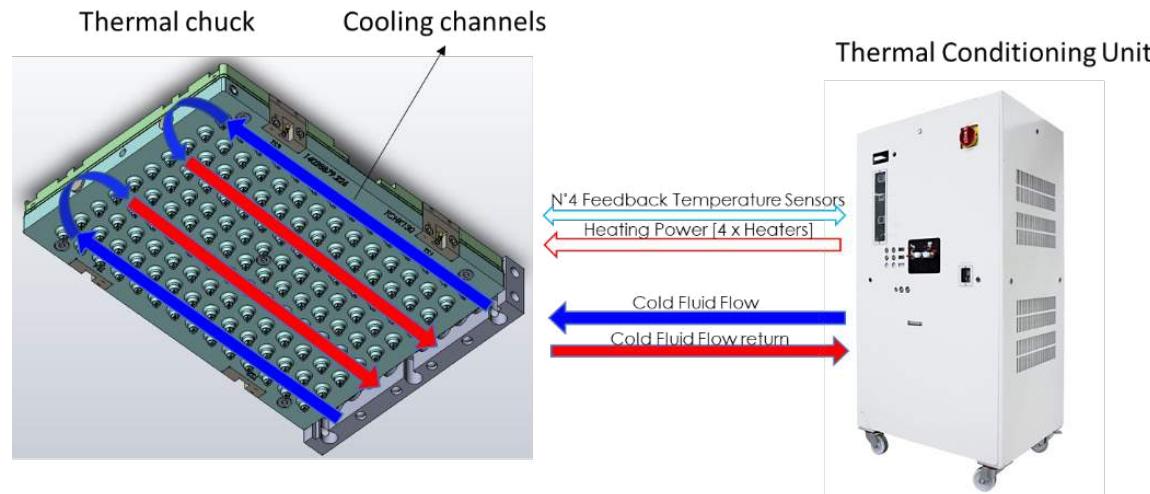


- Provision of in-situ calibration and measurement traceability to a next generation of ATE systems, based on a “reference fixture”
- Demonstration of the effectiveness of the improved ATE system in performing traceable dynamic temperature calibrations of the chucks [the thermal conditioned elements in direct contact with the MEMS]
- Demonstration of the effectiveness of the improved ATE system in performing traceable dynamic temperature calibrations of MEMS sensors

ATE for MEMS temperature testing



Thermal conditioning system



Project objectives of the SPEA testbed



Unit under test (UUT = MEMS)

- MEMS sensor to be tested in-situ under proven and traceable temperature conditions.

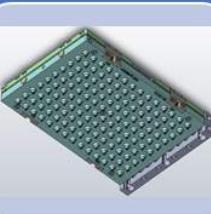


GOAL



Sensors socket

- Part used to keep in place the UTTs during the test and provide power and data connection.



Thermal chuck

- High thermal conductivity and diffusivity medium to provide homogeneous temperature to UUTs under transient conditions.
- Each UUT has a custom-designed thermal chuck.

Layers to be investigated to reach the goal.

Selected MEMS for demonstration

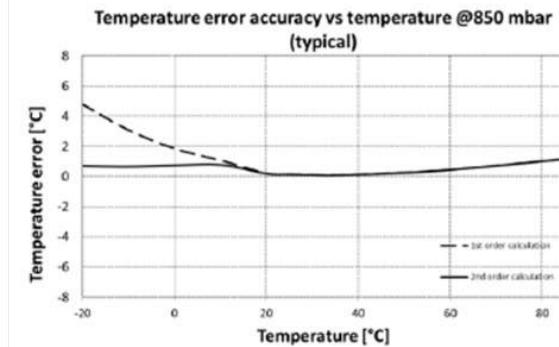


Features:

- Type: Pressure and Temperature sensor;
- Operating range: 300 to 1200 mbar, -20 to +85 °C
- Interface: I2C
- Temperature accuracy: ±2°C (**Factory calibration**)
- Dimensions: 3.3 x 3.3 x 2.75mm
- Integrated 24 bit ΔΣ ADC

TEMPERATURE OUTPUT CHARACTERISTICS ($V_{DD} = 3$ V, $T = 25^\circ\text{C}$ UNLESS OTHERWISE NOTED)

Parameter	Conditions	Min.	Typ.	Max	Unit
Relative Accuracy	-20...85°C, 300...1100 mbar	-2		+2	°C
Maximum error with supply voltage	$V_{DD} = 1.5$ V...3.6 V		±0.3		°C
Resolution RMS	OSR	8192 4096 2048 1024 512 256	0.002 0.003 0.004 0.006 0.009 0.012		°C





Process to reach the goal: a traceable calibration framework

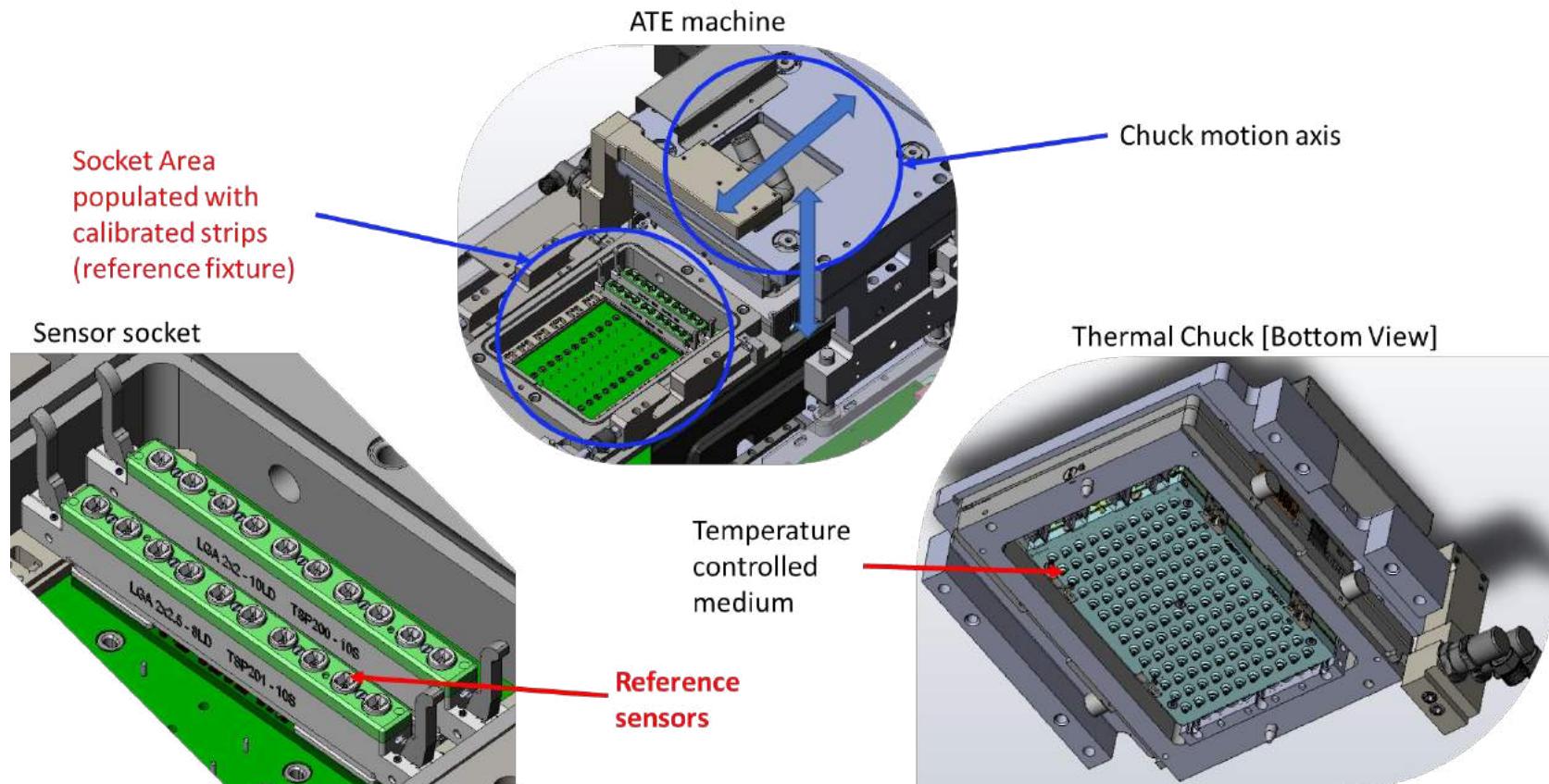
Developing a **reference fixture** to provide traceable temperature and electrical measurements to ATE machines.

Implementing **good metrology practice** in a novel ATE machine able to calibrate *in situ* electronic circuitry and reference temperature sensors.

- Optimizing the temperature control system.
- Validation of the generated thermal conditions to estimate **MEMS calibration uncertainty**.

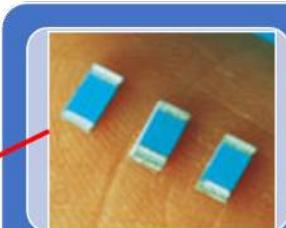
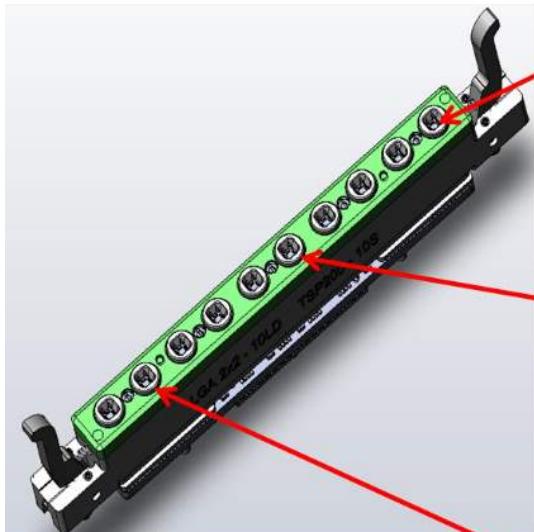
In situ MEMS testing/calibration under traceable temperature conditions.

Approach to investigate the ATE thermal stimulus: the reference fixture



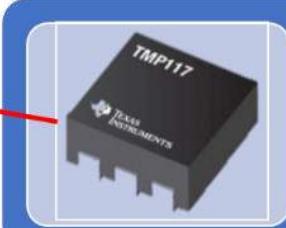
Approach to investigate the ATE thermal stimulus

Reference fixture: Instrumented sensor socket equipped with a network of **calibrated reference sensors**.



Reference PT100 Class A (thin film or SMD)

- Temperature range: -50°C ÷ +250°C
- Accuracy: better than 0.1°C after calibration
- Nominal resistance: 100 Ω at 0 °C
- Long term stability: < 0.04 % at 1000 h at 130 °C



Reference digital temperature sensors: Texas Instrument TMP117

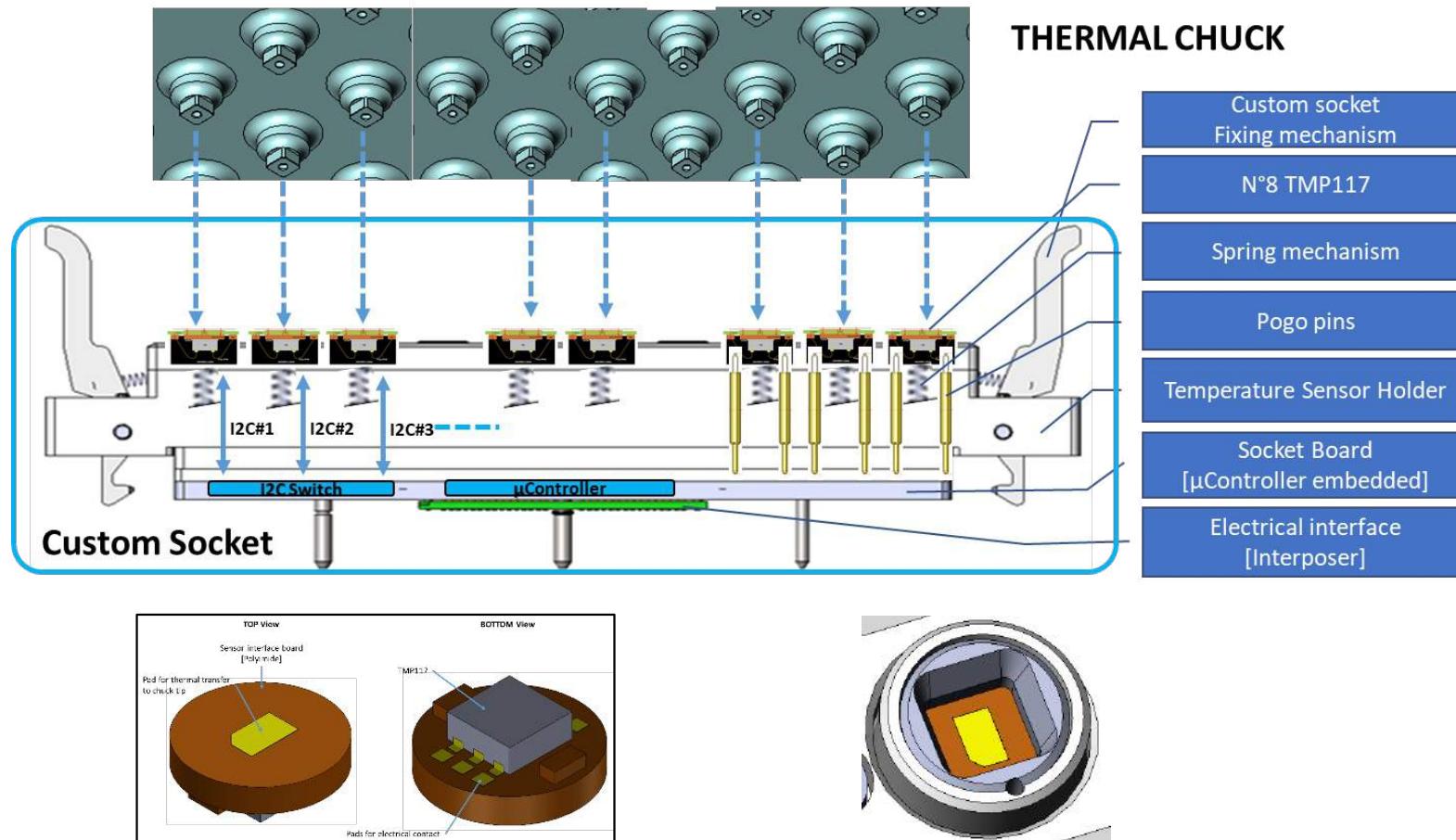
- Temperature range: -55°C ÷ +150°C
- Accuracy: < 0.1°C after calibration
- Resolution: 0.01°C
- Digital I2C bus



Golden device

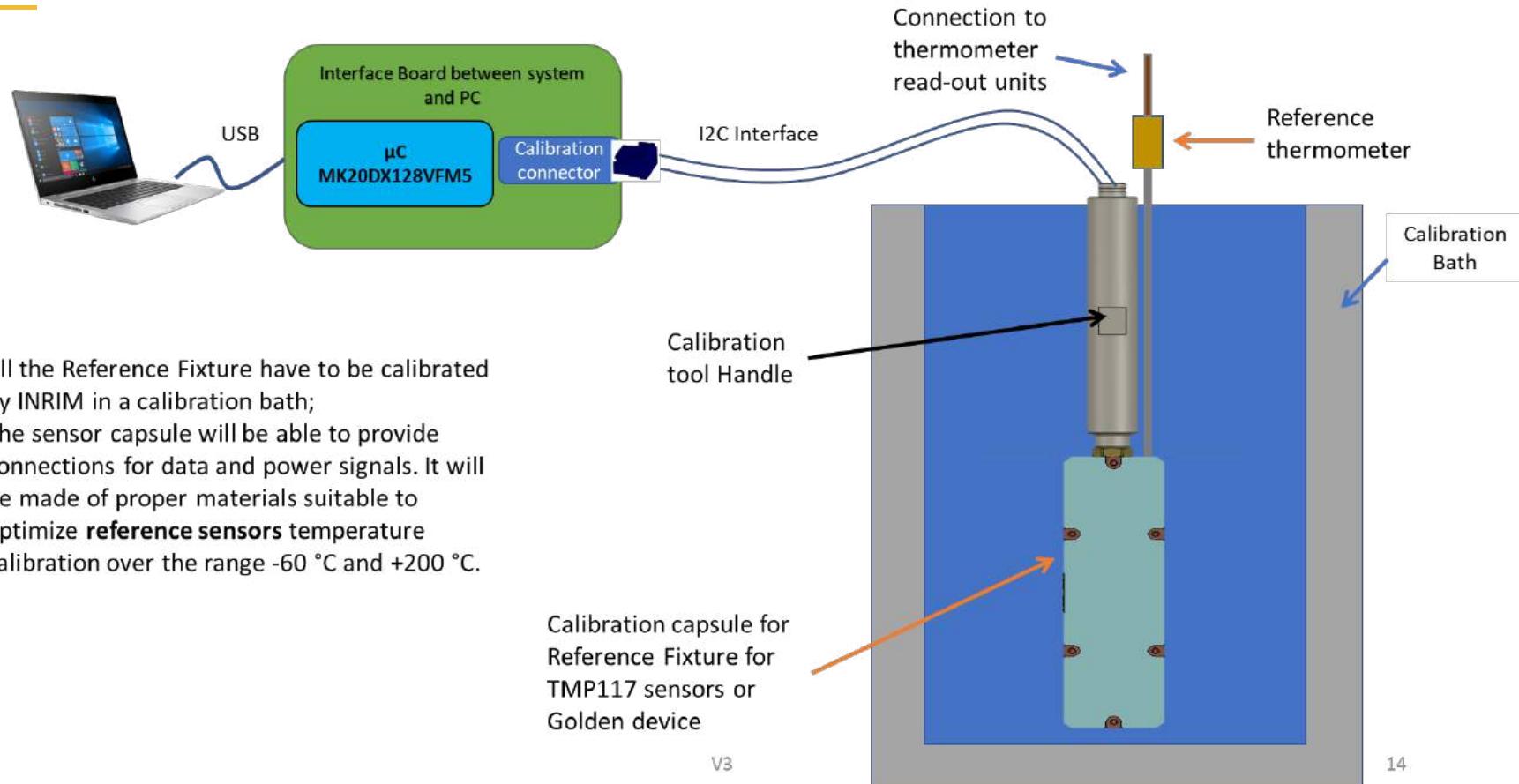
- Laboratory calibrated MEMS of the same kind of those under tests

Developing of a reference fixture with digital temperature sensors

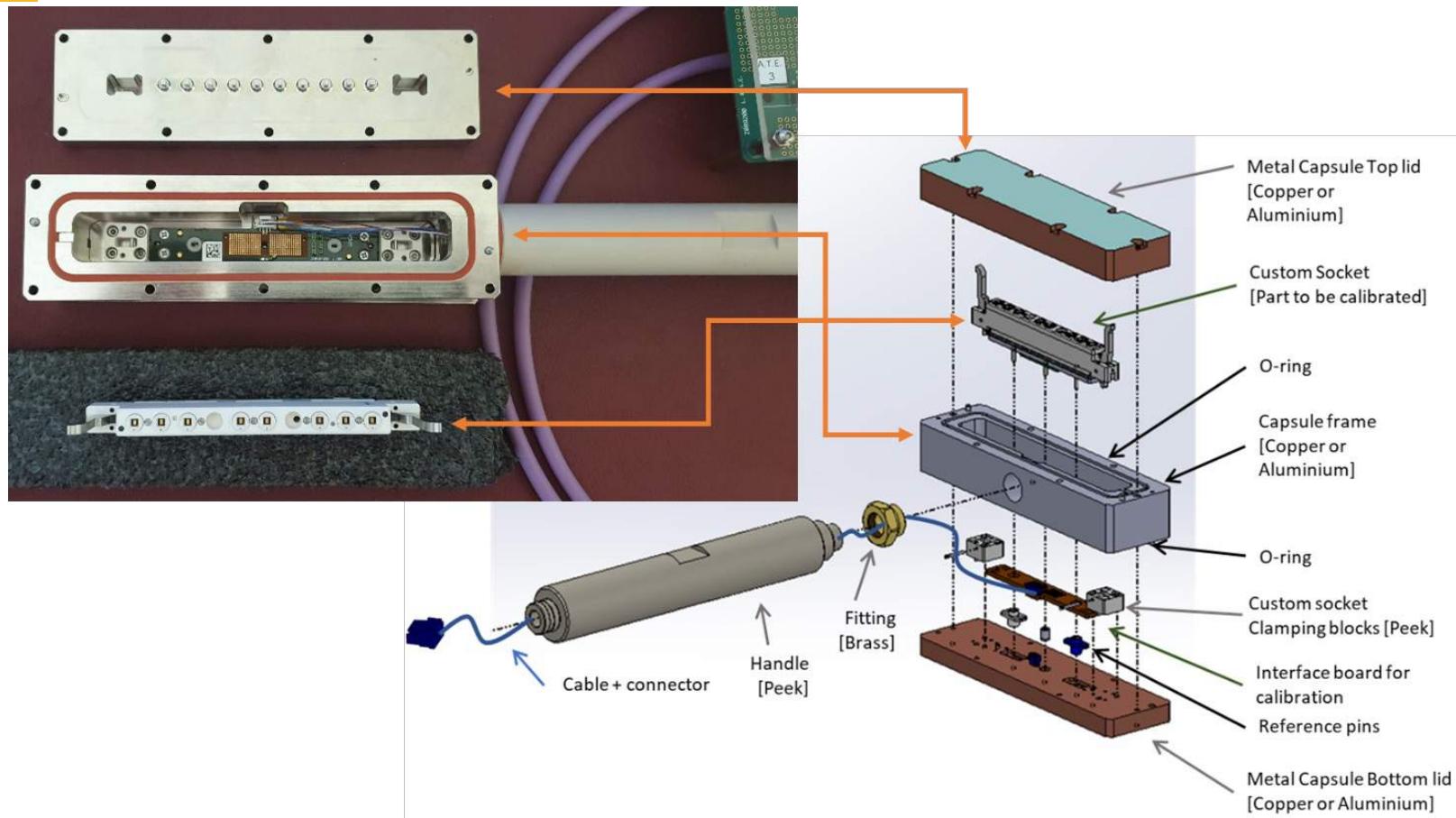


Laboratory calibration of the sensors aboard the reference fixture

- All the Reference Fixture have to be calibrated by INRIM in a calibration bath;
- The sensor capsule will be able to provide connections for data and power signals. It will be made of proper materials suitable to optimize **reference sensors** temperature calibration over the range -60 °C and +200 °C.



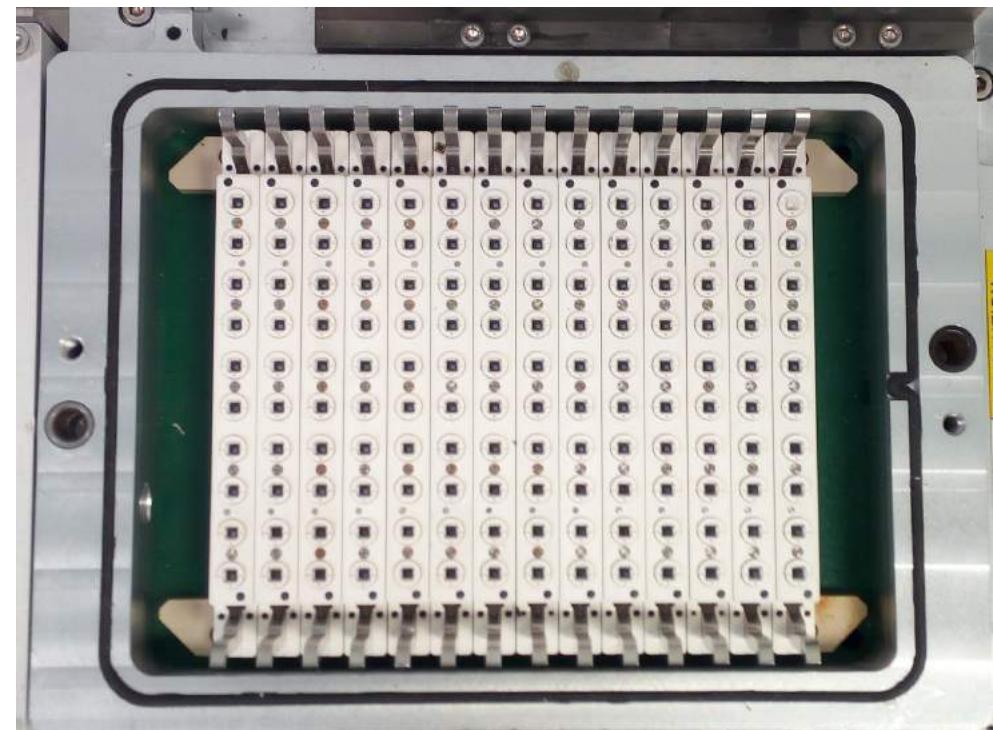
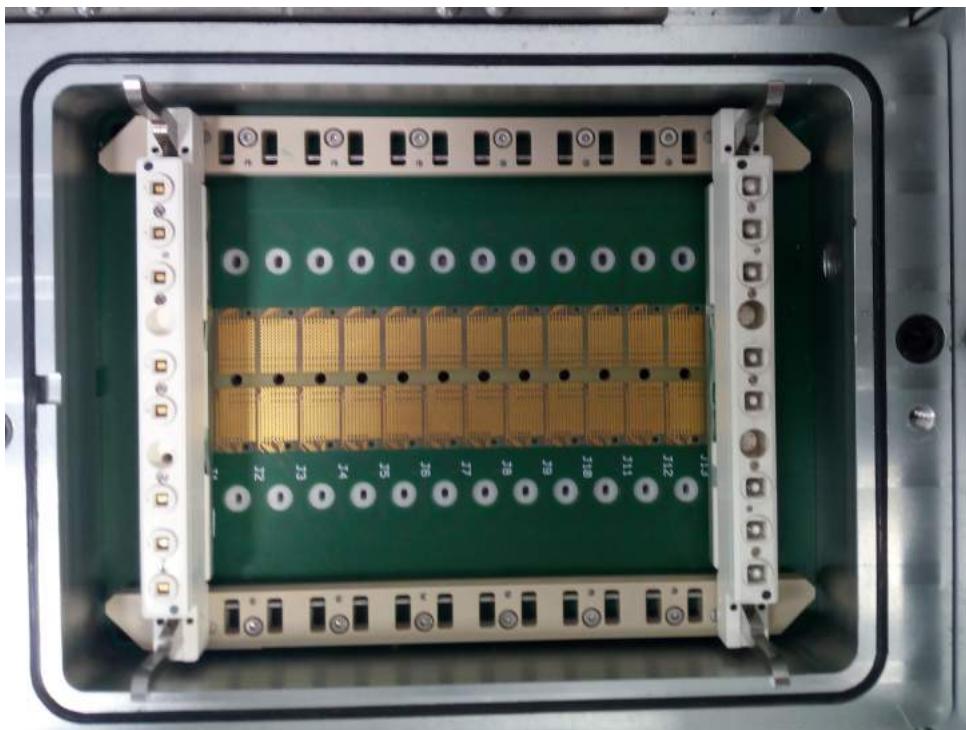
Calibration capsule layout



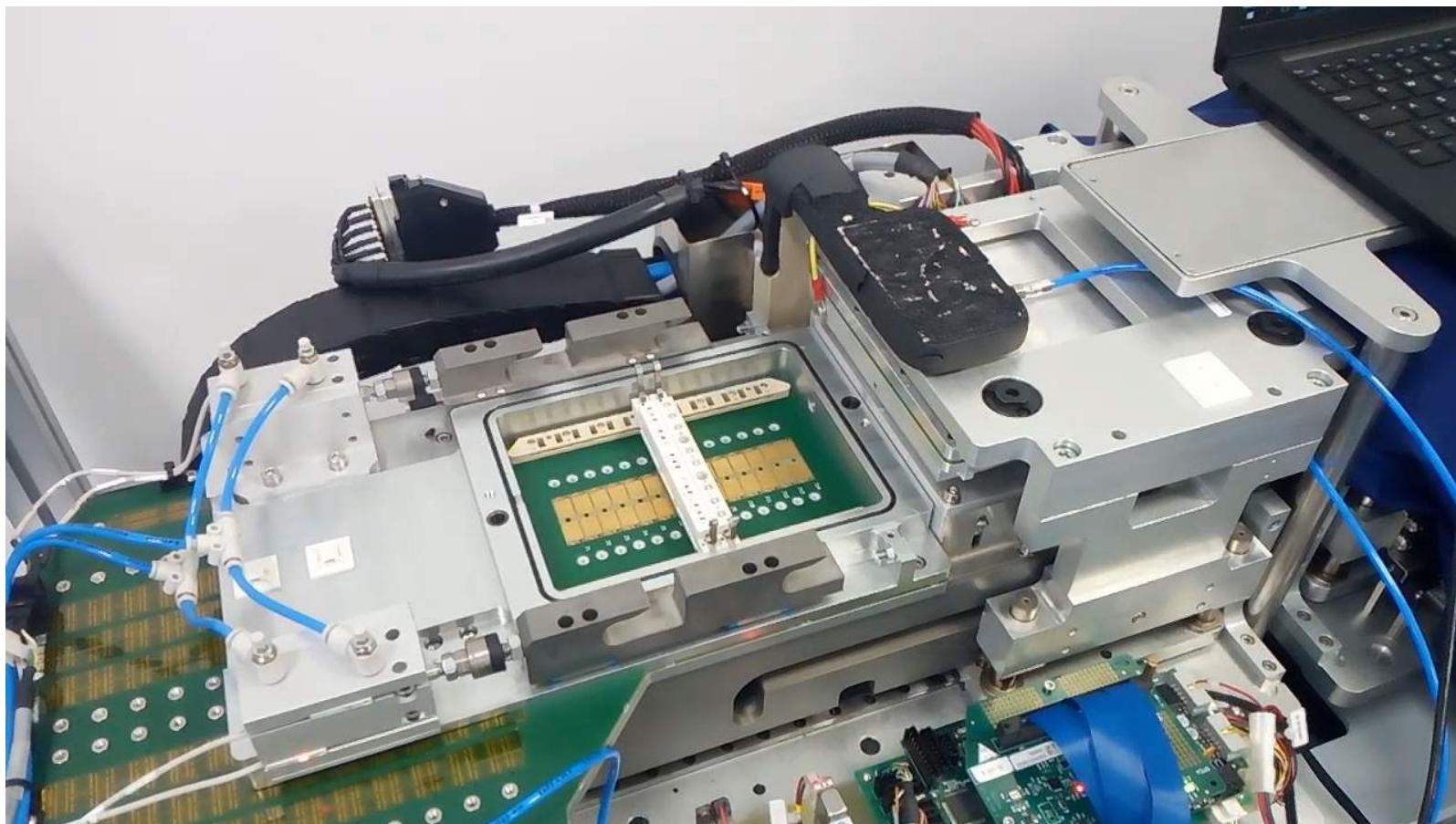
INRIM digital sensors calibration system



Reference fixture for in situ ATE calibration



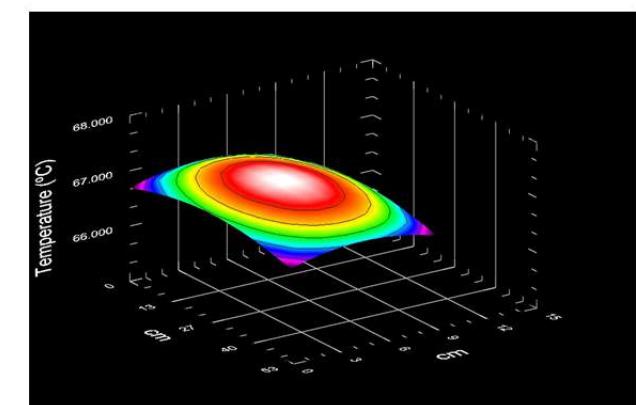
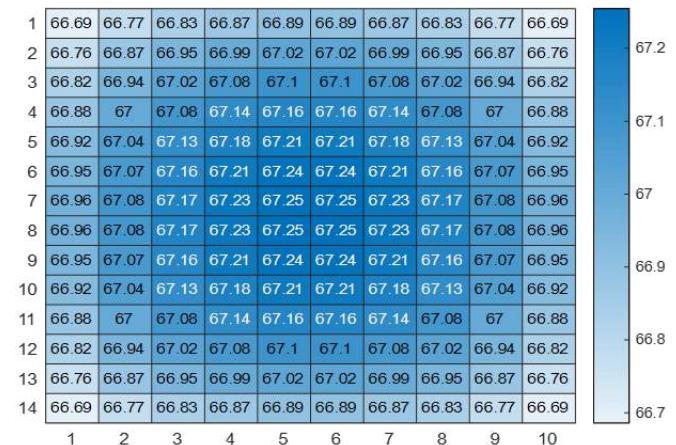
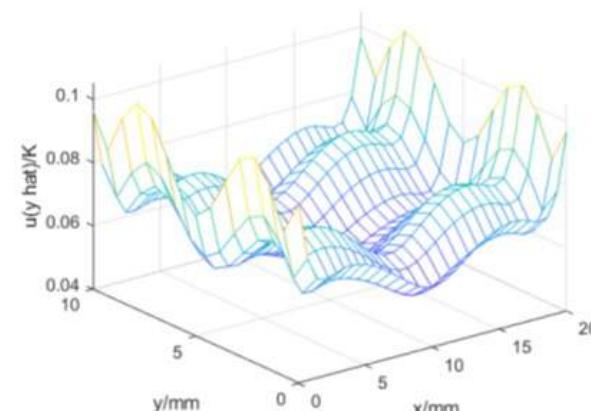
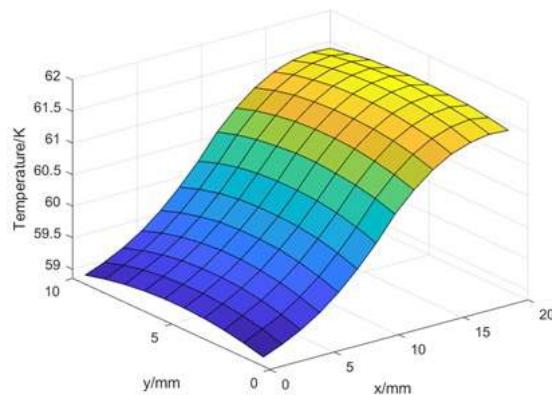
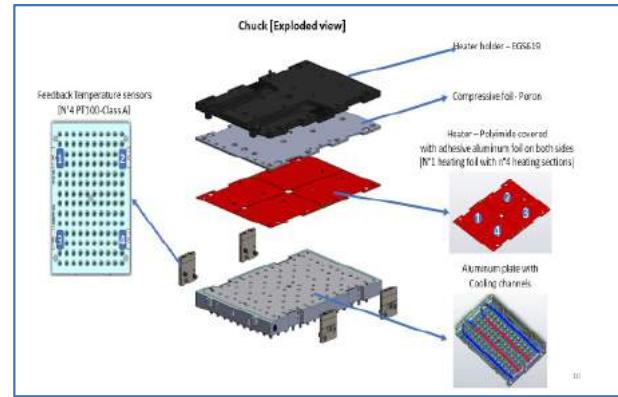
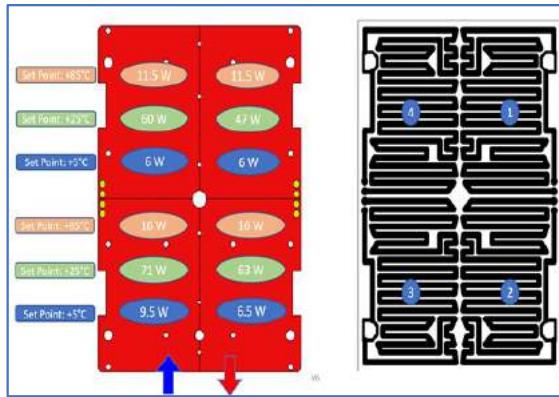
Reference fixture for in situ ATE calibration



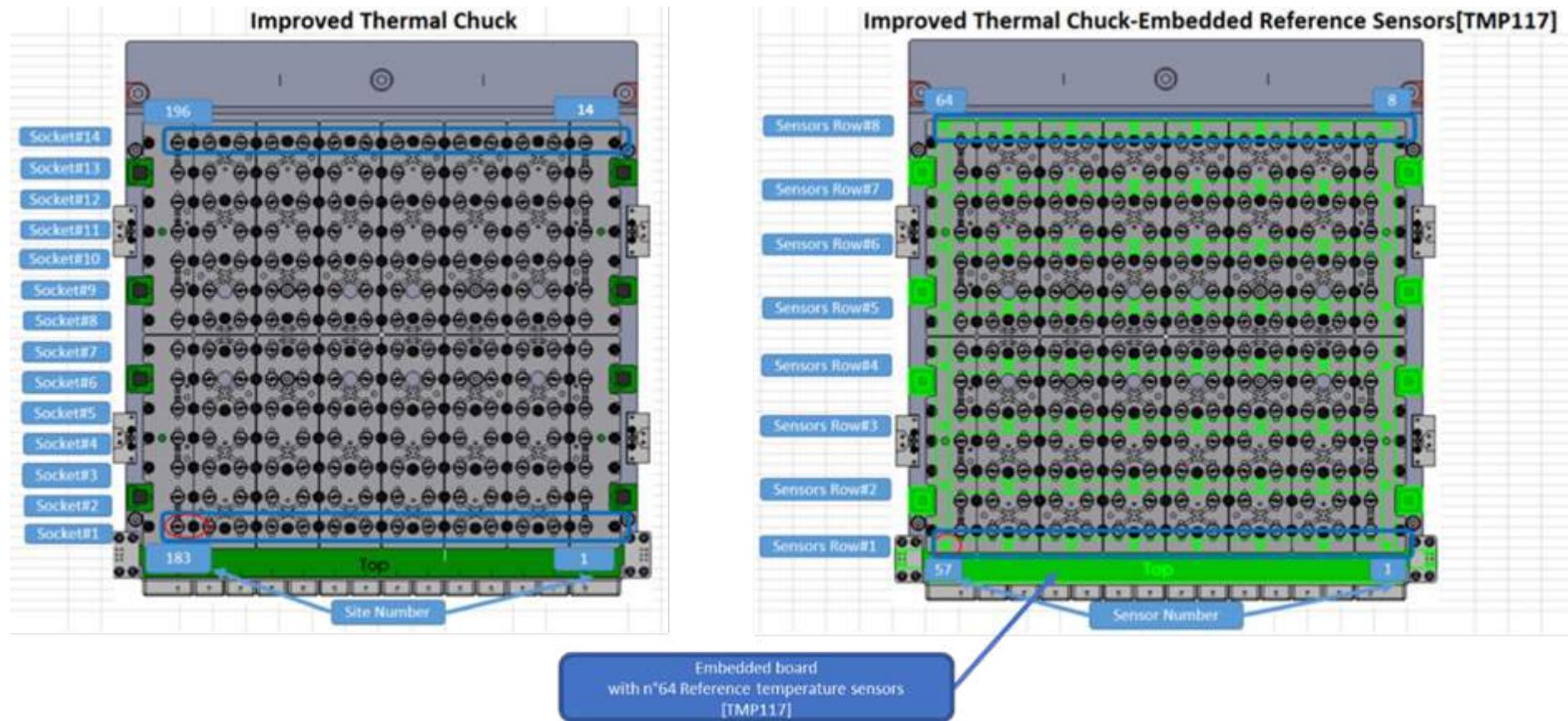
ATE metrological characterization

Sensor	TMP117 (Factory Calibrated)		
	°C	°C	°C
Set point temperature	5	35	80
Max temperature	7.27	35.71	79.71
Min temperature	5.70	35.20	76.42
Temperature homogeneity (max-min)	1.57	0.51	3.29
Mean temperature	6.45	35.56	78.59
Temperature stability	0.02	0.02	0.02
Set-point deviation (mean-set point)	1.45	0.56	-1.41

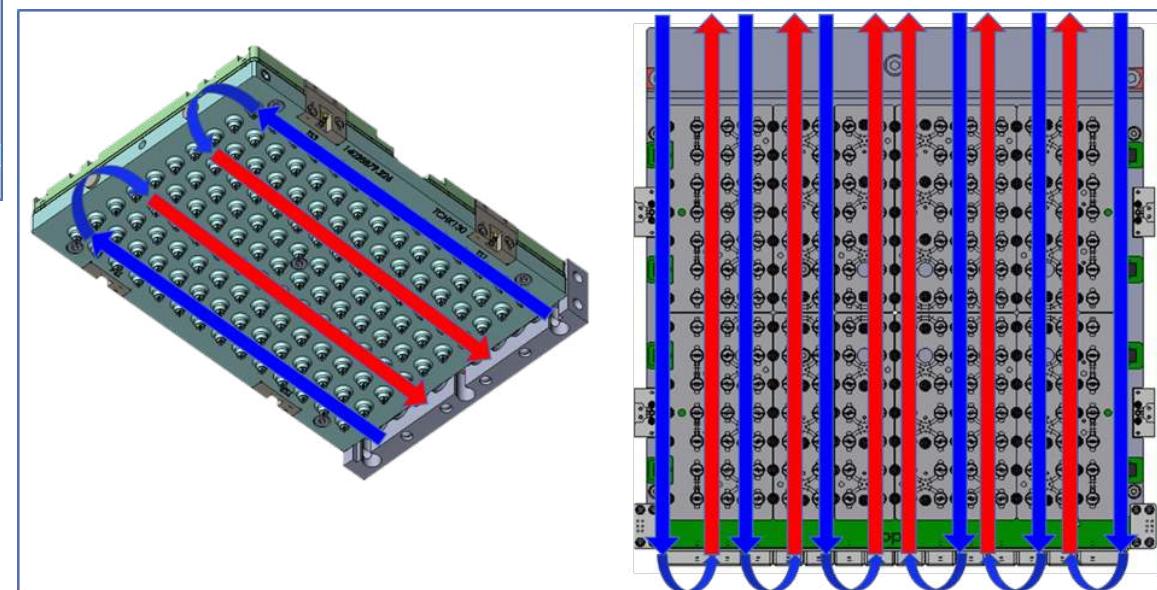
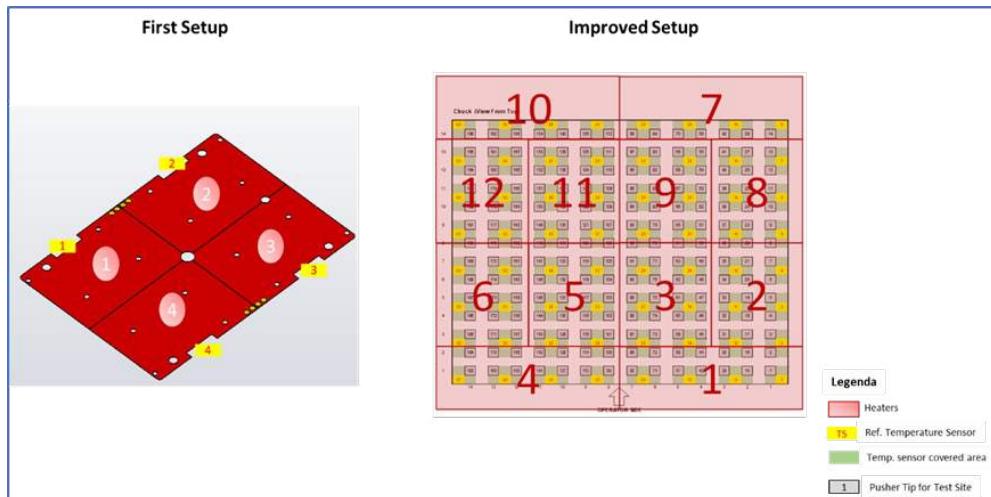
Thermal Modelling of SPEA ATE initial set-up and Optimization Strategy



Description of the improved thermal chuck set-up



Description of the improved thermal chuck set-up



Improved thermal chuck metrological characterization

Id_Sensors Row	Site1	Site2	Site3	Site4	Site5	Site6	Site7	Site8
8_TMP	4,95	4,91	5,02	5,05	5,06	4,98	4,88	4,92
7_TMP	5,01	4,98	5,03	5,09	5,07	4,98	4,92	5,02
6_TMP	5,03	5,01	5,04	5,05	5,09	5	4,99	5,09
5_TMP	5,06	5	4,98	5,03	5,02	5,02	4,97	5,14
4_TMP	5	4,97	4,92	4,96	4,97	4,94	4,94	5,2
3_TMP	4,93	4,9	4,88	4,91	4,91	4,84	4,88	4,97
2_TMP	4,88	4,9	4,9	4,91	4,91	4,85	4,88	5,02
1_TMP	5,01	4,92	4,91	4,96	4,93	4,92	4,91	5

Id_Sensors Row	Site1	Site2	Site3	Site4	Site5	Site6	Site7	Site8
8_TMP	35,02	34,97	35,01	34,99	34,98	34,98	34,97	35,03
7_TMP	35,01	35,02	35,02	35,02	35,02	34,99	34,98	35,02
6_TMP	35,01	34,99	35,03	35	35,02	34,98	34,96	35,05
5_TMP	34,98	34,99	34,98	35,02	34,99	35	34,97	35,05
4_TMP	35,01	35,01	34,96	35	35,01	35	34,98	34,97
3_TMP	34,98	35,01	35	35,02	35	34,97	35,01	35,05
2_TMP	34,98	35,03	35	34,99	35,01	34,99	35	35,01
1_TMP	35,02	35,02	34,96	35,01	35	34,98	35,02	34,99

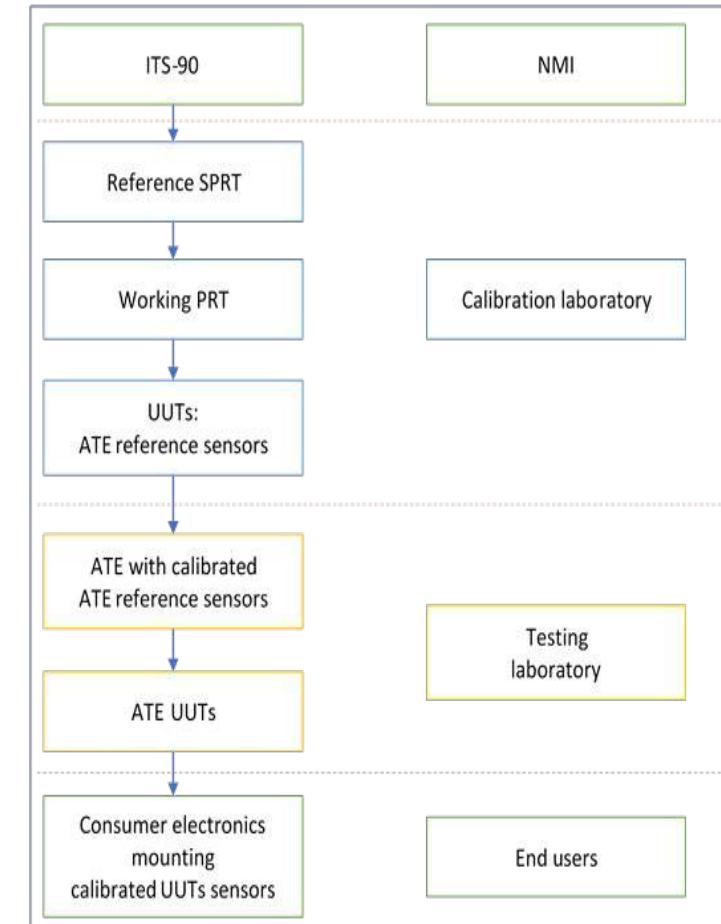
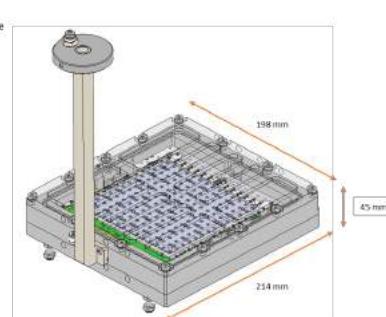
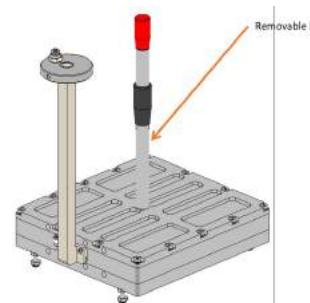
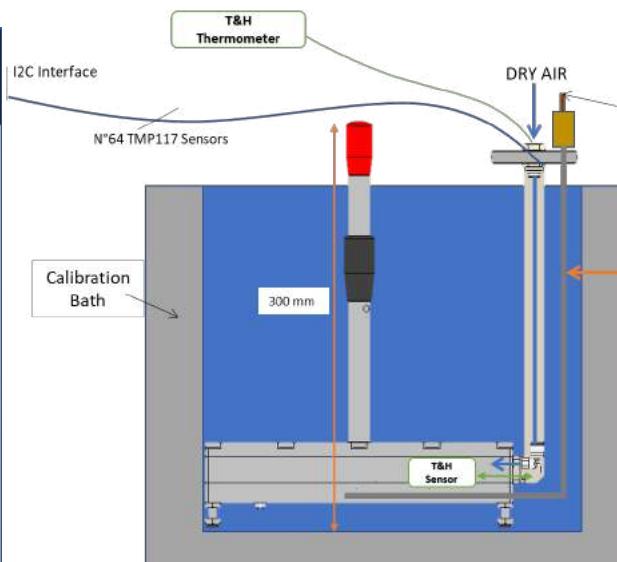
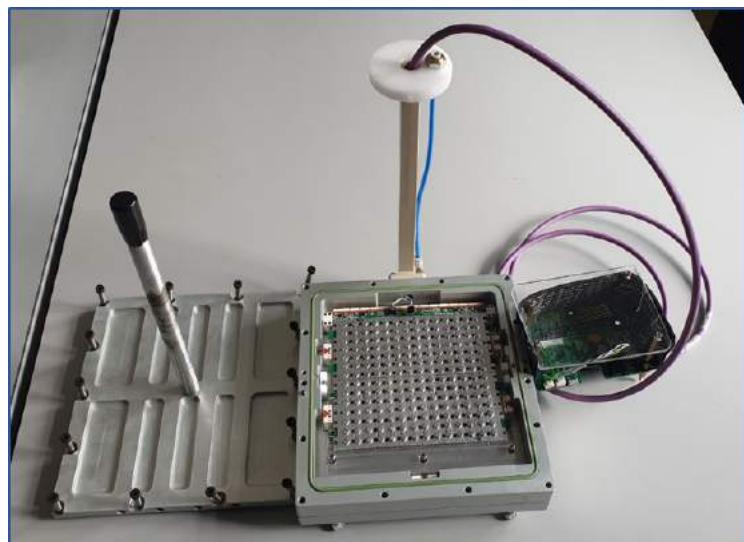
Id_Sensors Row	Site1	Site2	Site3	Site4	Site5	Site6	Site7	Site8
8_TMP	80,02	80,03	80,01	79,93	79,93	80,01	80,05	80,02
7_TMP	79,98	80,14	80,05	79,99	80,02	80,01	80,02	79,98
6_TMP	80,03	80,04	80,04	79,99	80,01	80	79,95	80,05
5_TMP	79,86	79,96	79,97	79,99	79,97	79,98	79,98	80,03
4_TMP	79,89	79,97	79,94	79,98	79,99	79,99	79,98	79,64
3_TMP	79,95	80,02	80	80,03	79,98	79,99	80,06	80,17
2_TMP	80,05	80,14	80,08	80,01	80,02	80,08	80,16	79,99
1_TMP	80,06	80,05	79,95	79,94	79,93	79,95	80,09	80,05

Sensor	TMP117 (Factory Calibrated)		
	°C	°C	°C
Set-point temperature	5	35	80
Max temperature	5.20	35.05	80.17
Min temperature	4.84	34.96	79.64
Temperature homogeneity (max-min)	0.36	0.09	0.53
Mean temperature	4.97	35.00	80.00
Temperature stability	0.02	0.02	0.02
Set-point deviation (mean-setpoint)	-0.03	0.00	0.00

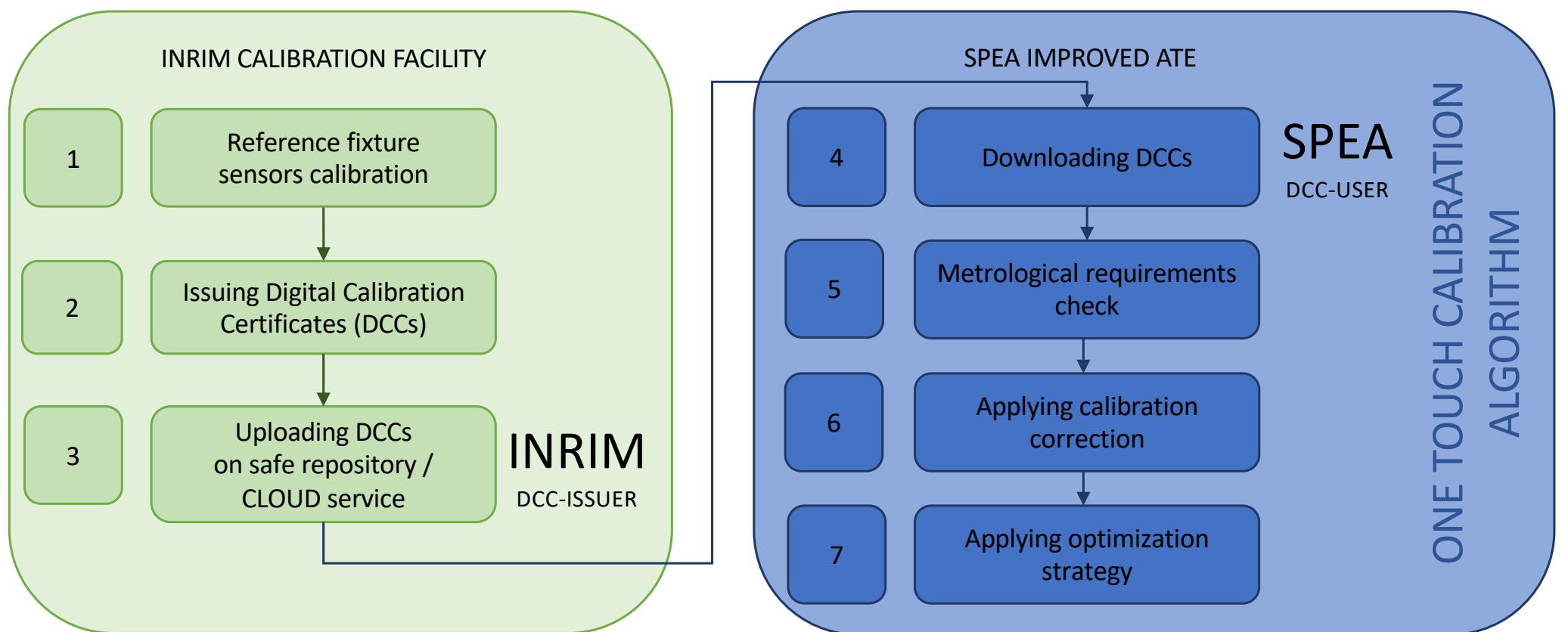
Improved thermal chuck metrological characterization

Section	All	All exc 2	12	11	9	8	6	5	3	2	10	7	4	1
°C	°C	°C	°C	°C	°C	°C	°C	°C	°C	°C	°C	°C	°C	°C
Mean	80.00	80.00	80	80.01	80	80	80	80.01	80.01	80	80	80	80	80.01
Max	80.17	80.14	80.14	80.05	80.02	80.05	80.14	80.08	80.08	80.17	80.03	80.05	80.06	80.09
Min	79.64	79.86	79.86	79.97	79.97	79.95	79.89	79.94	79.98	79.64	79.93	79.93	79.94	79.93
<i>u_t_homog</i>	0.21	0.08	0.08	0.02	0.02	0.03	0.08	0.04	0.04	0.21	0.04	0.04	0.03	0.05
<i>u_t_stability</i>	0.02	0.02	0.02	0.02	0.02	0.02	0.02	0.02	0.02	0.02	0.02	0.02	0.02	0.02
<i>U_ac</i>	0.43	0.20	0.19	0.12	0.11	0.12	0.19	0.13	0.13	0.43	0.13	0.13	0.13	0.14

Improved thermal chuck calibration and traceability chain



One-touch calibration algorithm for the reference sensors of the SPEA improved ATE systems



Considerazioni sui DCC



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 +39 011 340384
 inrim@inrim.it - www.inrim.it

pag. 1/5

CERTIFICATO DI TARATURA Certificate of Calibration

N. 21-0264-01 emesso il/issued on 2021-09-01

Oggetto /Item/Object	Sensore di temperatura integrato con uscita digitale/ IC temperature sensor with digital output
Modello/Tipo /Model/Type	TMP117
Identificazione /Serial number	RF1-1
Costruttore /Manufacturer	Texas Instruments
Data ricevimento oggetto /Date of receipt of item	2021-02-03
Data delle misure /Date of Measurements	Dal 2021-02-24 al 2021-02-25
Procedura applicata /Applied procedure	//
Registro di laboratorio /Laboratory record book	Commissa 21-0264
Committente /Customer	SPEA SpA
Indirizzo /Address	Via Torino, 16, 10088 Volpiano TO
Responsabile attività /Responsible for the activities	Autorizzato da /Authorized by Funzione /Function (Denis Smorgan)
	(Michela Segà)

Il presente certificato attesta la riferibilità delle misure ai Campioni Nazionali (D.M. n. 691/1993) e alle unità di misura accreditate all'INRIM o in altri Istituti Metrologici Primari ai sensi della Legge n. 273/1991.
 I risultati qui riportati si riferiscono esclusivamente agli oggetti descritti e alle condizioni di misura specificate.
 L'autenticità del presente certificato è attestata dall'apposizione in originale delle firme e del timbro a secco.
 La riproduzione del presente certificato è ammessa solo in copia conforme integrale; la riproduzione in copia conforme parziale è ammessa solo su autorizzazione scritta rilasciata dall'INRIM, da riportare con il numero di protocollo sulla riproduzione.

ACCREDIA



CERTIFICATO DI TARATURA

Certificate of Calibration

N. 21-0264-01 emesso il/issued on 2021-09-01 - pag. 3/5

Nella tabella 1 è riportato il bilancio di incertezza della parte fissa (u_{fix}) relativa al processo di misura. Esso include i contributi di incertezza dovuti ai termometri di riferimento ed alla sua catena di misura, al mezzo di confronto e alla risoluzione dell'UUT.

Table 1 shows the uncertainty budget of the fixed part (u_{fix}) related to the measurement process. It includes the contributions of uncertainty due to the reference thermometers and its measurement chain, the comparison medium and the UUT resolution.

Tabella 1 / Table 1. Stima dei contributi di incertezza fissi del processo di misura / Evaluation of the fixed uncertainty contributions of the measurement process.

Code	Contributions	Units	Value	Multiplicative factor	Pdf	Divisor	St. Dev	(St.Dev)^2
UNCERTAINTIES OF THE REFERENCE CALIBRATION SYSTEM								
1aa	PRT calibration	°C	0.020	1	Normal	2	0.010	1.00E-04
1ab	PRT long-term stability	°C	0.050	1	Rectangular	3.46	0.014	2.08E-04
1ac	PRT fitting	°C	0.025	1	Normal	1	0.025	6.25E-04
1ba	DAQ calibration or Accuracy	°C	0.010	1	Normal	2	0.005	2.50E-05
1bb	DAQ stability over time	°C	0.010	1	Rectangular	3.46	0.003	8.33E-06
1bc	DAQ resolution	°C	0.001	1	Rectangular	3.46	0.000	8.33E-06
UNCERTAINTIES OF THE UUT								
2ab	UUT resolution	°C	0.001	1	Rectangular	3.46	0.000	8.33E-08
Combined standard uncertainty - u_{fix}								
		°C					u_c	0.03

L'incertezza di taratura riportata nella tabella 2 include il contributo u_{fix} composto coi contributi di ripetibilità dell'UUT (u_{UUT_rep}) e della temperatura (u_{REF_rep}), e all'omogeneità di temperatura rilevata all'interno del blocco equalizzatore ($u_{homog_cal_tool}$). Pertanto l'incertezza di taratura in ogni singolo punto di taratura è calcolato come:

The calibration uncertainty shown in table 2 includes the u_{fix} contribution composed with the UUT repeatability contribution of the UUT (u_{UUT_rep}) and the reference temperature (u_{REF_rep}), and the homogeneity of temperature within the equalizer block ($u_{homog_cal_tool}$). Finally, the calibration uncertainty in each single calibration point is calculated as:

$$U = \sqrt{u_{fix}^2 + u_{UUT_rep}^2 + u_{REF_rep}^2 + u_{homog_cal_tool}^2}$$

I risultati della taratura sono riportati nella tabella 2.

The calibration results are shown in table 2.

Tabella 2 / Table 2. Risultati della taratura / Calibration Results

N. ordine	t_{NOM} (°C)	t_{RIF} (°C)	t_{UUT} (°C)	$t_{UUT-RIF}$ (°C)	U (°C)
1	5	4.58	4.65	0.07	0.07
2	15	14.57	14.64	0.07	0.06
3	25	24.57	24.61	0.04	0.06
4	35	34.56	34.61	0.05	0.06
5	60	59.59	59.63	0.04	0.06
6	80	79.62	79.64	0.02	0.07
7	85	84.62	84.64	0.02	0.07

Controllato da:
Checked by: (Vito Ferriola)

Considerazioni sui DCC

1. SITE AND MEASUREMENT CONDITIONS

INRIM - Laboratorio di igrometria primaria / Primary hygrometry laboratory.
 Temperatura dell'aria / Air temperature: $25^{\circ}\text{C} \pm 3^{\circ}\text{C}$
 Umidità Relativa / Relative humidity: $50\% \text{rh} \pm 20\%$

2. RESULTS AND EXPANDED UNCERTAINTIES

The calibration results are shown in table 1.

Table 1. Calibration Results

N. ordine	t_{NOM} ($^{\circ}\text{C}$)	t_{RIF} ($^{\circ}\text{C}$)	t_{UUT}	$t_{\text{UUT-RIF}}$ ($^{\circ}\text{C}$)	U ($^{\circ}\text{C}$)
1	5	4.58	4.65	0.07	0.07
2	15	14.57	14.64	0.07	0.06
3	25	24.57	24.61	0.04	0.06
4	35	34.56	34.61	0.05	0.06
5	60	59.59	59.63	0.04	0.06
6	80	79.62	79.64	0.02	0.07
7	85	84.62	84.64	0.02	0.07

Legend:

t_{NOM}	= ; Nominal temperature
t_{RIF}	= Reference temperature
t_{UUT}	= UUT reading
U	= Calibration expanded uncertainty.

The expanded uncertainty U is expressed as the standard uncertainty multiplied by the coverage factor $k = 2$, which for a normal distribution corresponds to a coverage probability of approximately 95%. In assessing the uncertainty, the long-term stability of the UUT was not considered.

The UUT reading can be corrected using the correction function described by the following polynomial:

$$y = a_0 + a_1 \cdot x^1 + a_2 \cdot x^2 + a_3 \cdot x^3 + a_4 \cdot x^4 + \dots + a_n \cdot x^n$$

HUMAN READABLE DCC

ACCREDIA





Grazie per aver partecipato!